

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Attn: APPLICATION BRANCH**  
Tetsuji TOGAWA et al. : Attorney Docket No. 2004\_0624  
Serial No. NEW :  
Filed April 20, 2004 :

APPARATUS FOR MANUFACTURING  
SEMICONDUCTOR DEVICE  
**(Rule 1.53(b) Continuation**  
of Serial No. 09/358,252,  
**Filed July 20, 1999)**

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

**CLAIM OF PRIORITY UNDER 35 USC 119**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicants in the above-entitled application hereby claim the date of priority under the International Convention of Japanese Patent Application No. 221100/1998, filed July 21, 1998, as acknowledged in the Declaration of this application.

A certified copy of said Japanese Patent Application is of record in parent application Serial No. 09/358,252, filed July 20, 1999.

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Respectfully submitted,

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